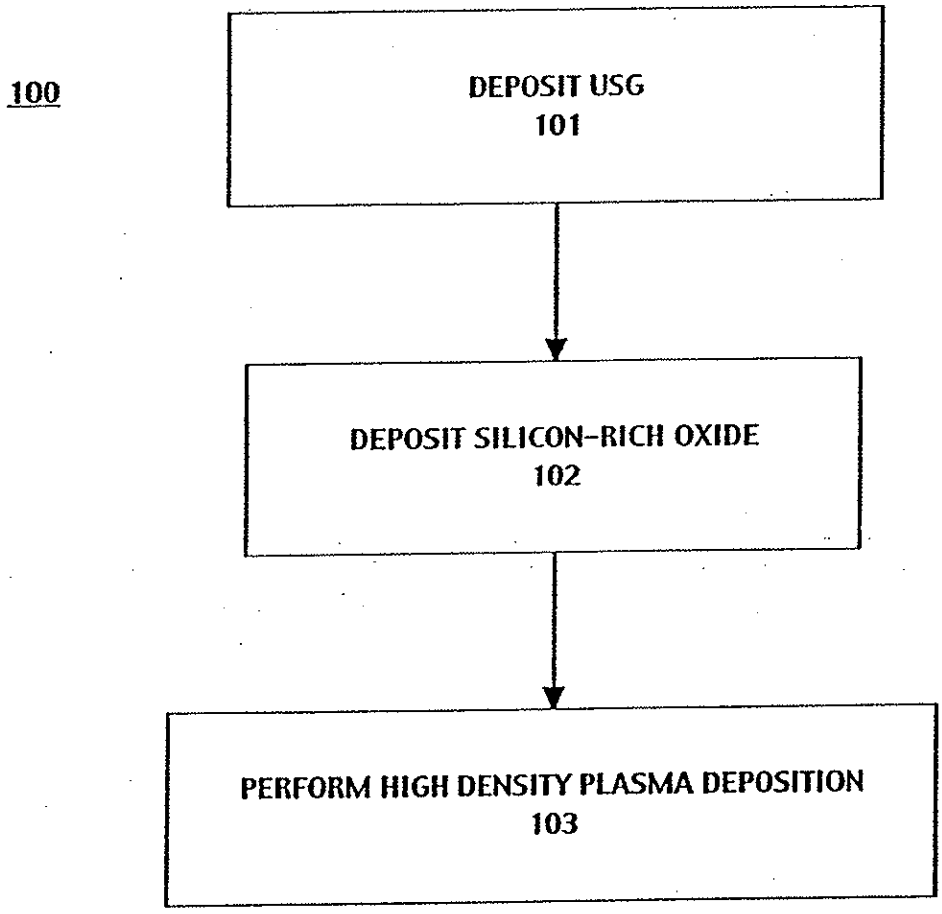

100
DEPOSIT USG
101
DEPOSIT SILICON-RICH OXIDE
102
PERFORM HIGH DENSITY PLASMA DEPOSITION
103

FIG. 1

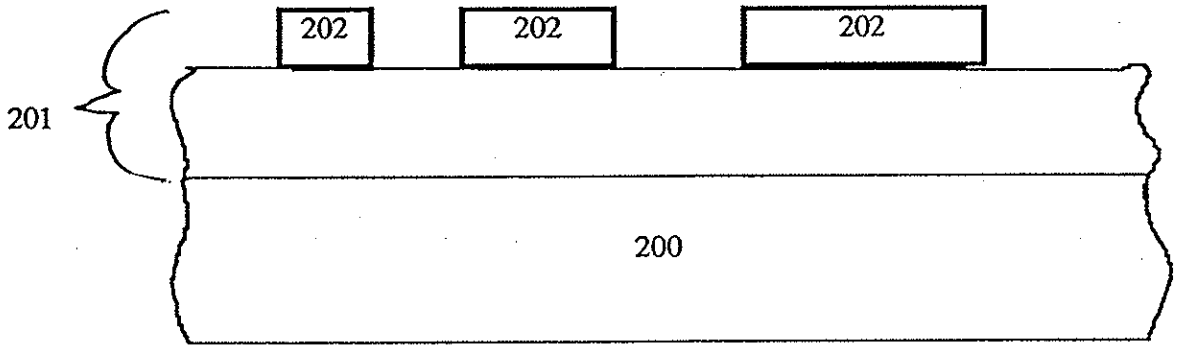


FIG. 2

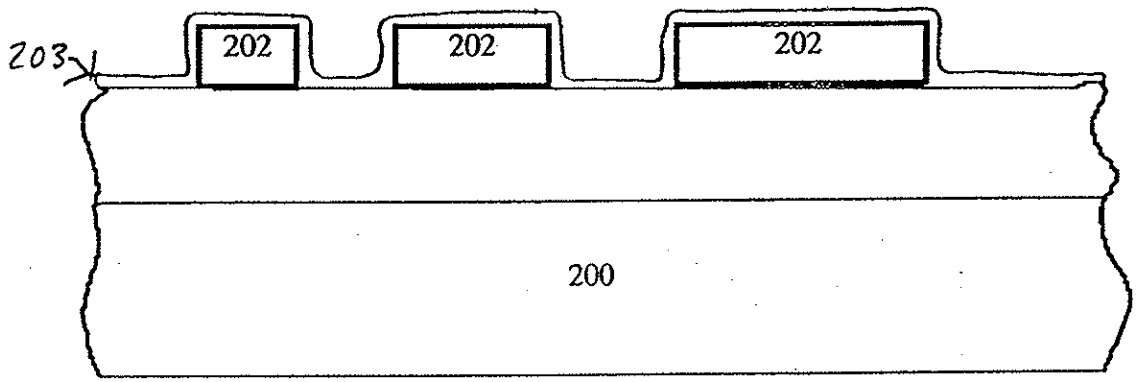


FIG. 3

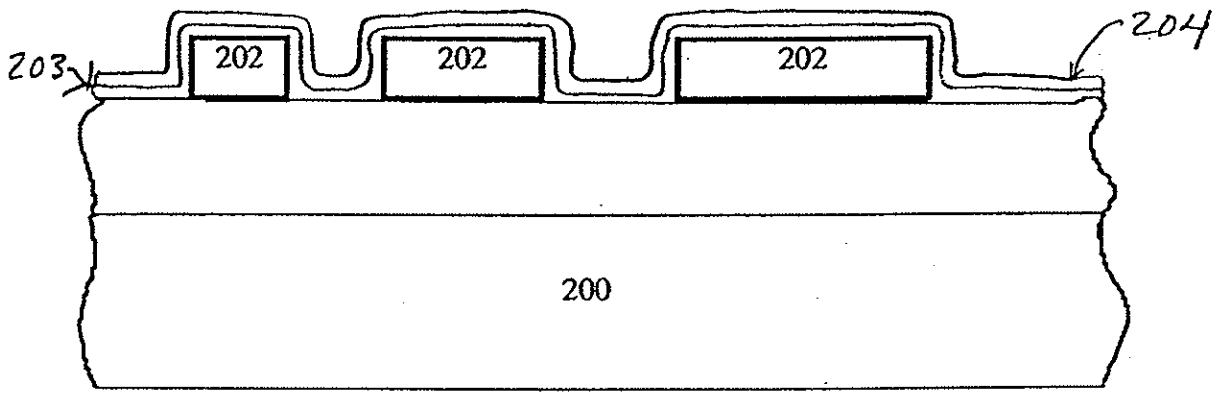


FIG. 4

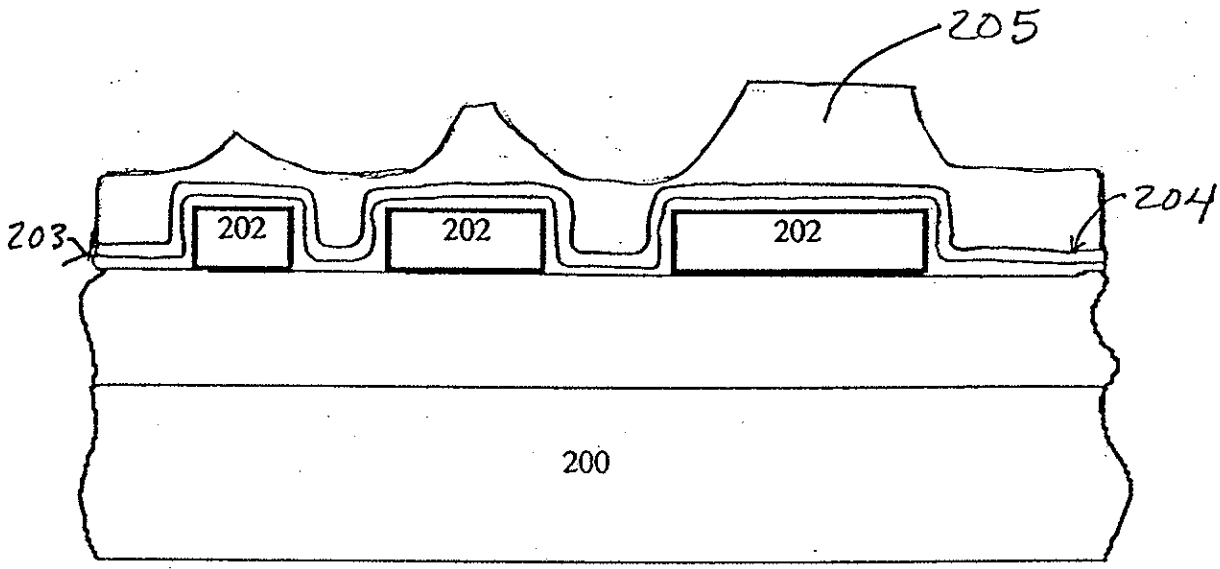


FIG. 5